



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 7849

SERIAL NUMBER 09/843,650	FILING DATE 04/27/2001 RULE	CLASS 361	GROUP ART UNIT 2841	ATTORNEY DOCKET NO. IIZ 123
-----------------------------	-----------------------------------	--------------	------------------------	-----------------------------------

APPLICANTS

Shinji Ohuchi, Tokyo, JAPAN;
Yasushi Shiraishi, Tokyo, JAPAN;
Yasuo Tanaka, Tokyo, JAPAN;

**** CONTINUING DATA *********** FOREIGN APPLICATIONS *******
JAPAN 2000-128764 04/28/2000**IF REQUIRED, FOREIGN FILING LICENSE GRANTED**
** 06/22/2001

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after
Verifier and Acknowledged	Allowance <i>Steven M. Rabin</i> Examiner's Signature Initials
ADDRESS	STATE OR COUNTRY JAPAN
RABIN & CHAMPAGNE, P.C. Steven M. Rabin SUITE 500 1101 14th STREET Washington ,DC 20005	SHEETS DRAWING 23
	TOTAL CLAIMS 22
	INDEPENDENT CLAIMS 3

TITLE

Semiconductor apparatus and method for fabricating the same

FILING FEE RECEIVED 876	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
----------------------------	---	---